JC20 Rec'd PCT/PTO 1 3 MAY 2005

AMENDMENT UNDER ARTICLE 19(1)

CLAIMS

- 1. An epitaxial growth method comprising: supporting a substrate for growth with a substrate supporter, forming a compound semiconductor layer comprising 3 or 4 elements on the substrate for growth by metal organic chemical vapor deposition, polishing the substrate so that an angle of gradient is 0.00° to 0.03° or 0.04° to 0.10° with respect to (100) direction in an entire effective area of the substrate, and forming the compound semiconductor layer to be $0.5\mu m$ thick or more on the substrate by using the substrate for growth.
- 2. The epitaxial growth method as claimed in claim 1, further comprising: forming a buffer layer on the substrate for growth, and forming the compound semiconductor layer on the buffer layer.
- 3. The epitaxial growth method as claimed in claim 1 or 2, wherein the compound semiconductor layer is a III-V group compound semiconductor layer containing at least As.
- 4. The epitaxial growth method as claimed in claim 3, wherein the compound semiconductor layer is an InGaAs layer

or an InAlAs layer.

- 5. The epitaxial growth method as claimed in claim 3 or 4, wherein the substrate for growth is a semiconductor crystal substrate having dislocation density of 5000cm⁻² or less.
- 6. The epitaxial growth method as claimed in claim 5, wherein the substrate for growth is an InP substrate.
- 7. A substrate for epitaxial growth used for an epitaxial growth method in which a compound semiconductor layer comprising 3 or 4 elements is formed on the substrate for growth by metal organic chemical vapor deposition, wherein an angle of gradient is 0.00° to 0.03° or 0.04° to 0.10° with respect to (100) direction in an entire effective area of the substrate.
- 8. The substrate for epitaxial growth as claimed in claim 7, wherein the substrate is a semiconductor crystal substrate having dislocation density of 5000cm⁻² or less.
- 9. The substrate for epitaxial growth as claimed in claim 7 or 8, wherein the substrate is an InP substrate.